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RESPONSE UNDER 37 CFR §1.116
EXPEDITED PROCEDURE
GROUP ART UNIT 2811

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No.: 10/625,546

Confirmation No.: 8197

In re Application of:

Yutaka HIROSE et al.

Group Art Unit: 2811

Filed: July 24, 2003

Examiner: Nitin Parekh

For: CONTACT FORMATION METHOD
AND SEMICONDUCTOR DEVICE

AMENDMENT UNDER 37 CFR §1.116

Mail Stop AF
Commissioner for Patents
BOX AF
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

In response to the Office Action mailed January 4, 2005
please amend the above-identified application as follows: